

L Number	Hits	Search Text	DB	Time stamp
27	23442	SOI (silicon near on near insulator) (silicon-on-insulator)	USPAT; US-PPGPUB; EPO; JPO; DERWENT; IBM TDB USPAT; US-PPGPUB; EPO; JPO; DERWENT; IBM TDB USPAT; US-PPGPUB; EPO; JPO; DERWENT; IBM TDB	2004/06/24 14:19
28	204253	heat\$3 near5 remov\$3		2004/06/24 14:19
29	854	(SOI (silicon near on near insulator) (silicon-on-insulator)) and (heat\$3 near5 remov\$3)		2004/06/24 14:19

L Number	Hits	Search Text	DB	Time stamp
7	2736	(((((silicon near on insulator) (SOI))) and ((silicon near oxide) (sio."sub.2"))) and (silicon near (substrate wafer))) and (silicon near layer)) and ((refractory near metal) (titanium near tungsten) (titanium near nitride))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/14 15:11